

■ Development Project of “**New Hf Precursors**”

□ New Hf Precursor

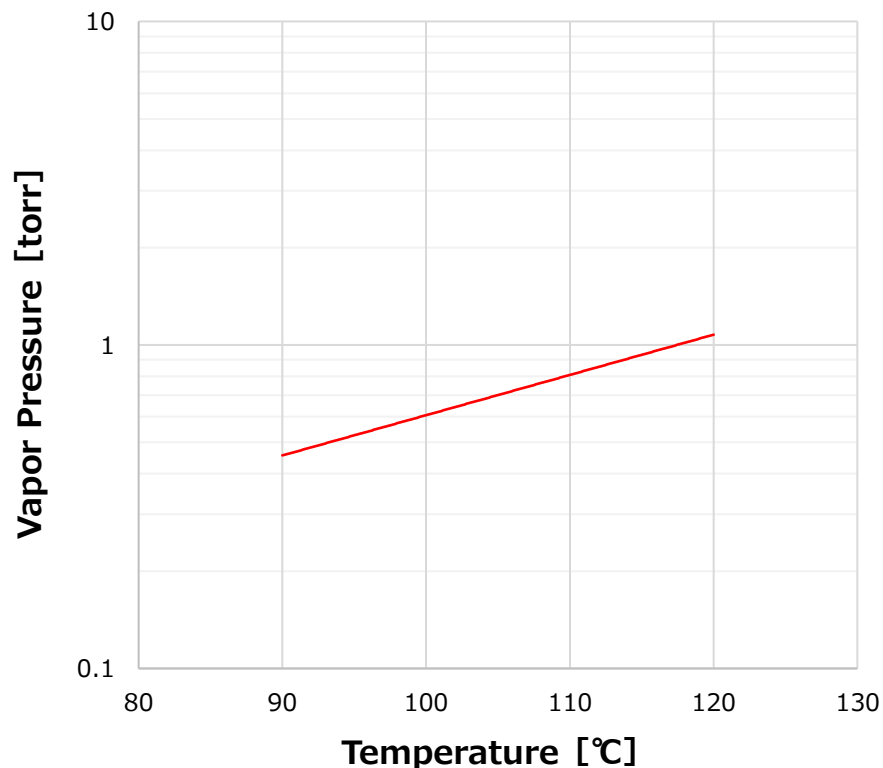
■ MO type

- Code Name : [HOC-IV](#)
- State : [Liquid](#)

■ Target

- Composition : [HfO₂](#)
- Application : [Capacitor](#)

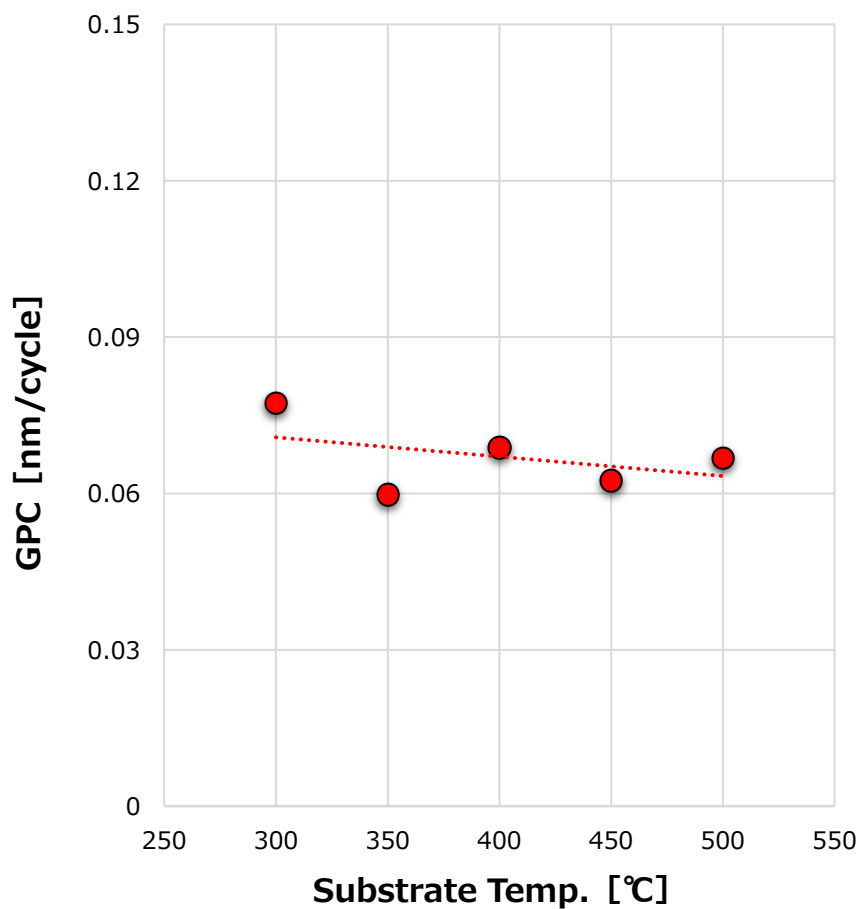
[Vapor Pressure curve]



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ALD evaluation about HOC-IV

[Growth rate vs Substrate Temp.]



[Refractive index vs Substrate Temp.]

